

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 21, 2024

IGI Report Number

DESCRIPTION

Shape and Cutting Style

Measurements

LG666415087

LABORATORY GROWN DIAMOND

EMERALD CUT

10.84 X 7.43 X 4.88 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

3.85 CARATS

H

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

EXCELLENT

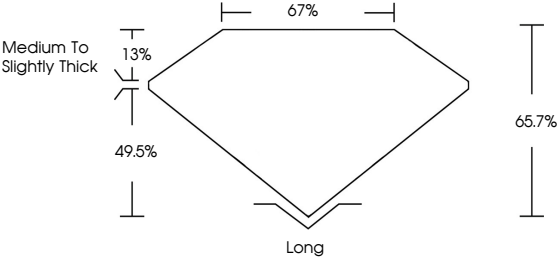
NONE

Inscription(s)

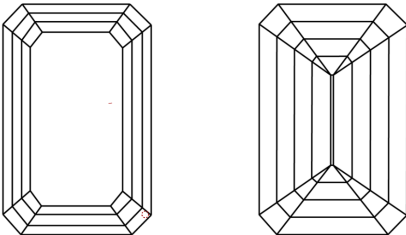
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG666415087

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY

D E F G H I J



Faint

Very Light

Light

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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
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IGI

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EMERALD CUT

3.85 CARATS

H

VS 1

65.7%

67%


Medium to Slightly Thick

Long

EXCELLENT

EXCELLENT

NONE

 LG666415087

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